



Attorney Docket No. SEL 194

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Hideomi SUZAWA et al

Serial No.: 09/615,449

Filed: July 13, 2000

Art Unit: 2814

Examiner: Hoa B. Trinh

For: WIRING AND MANUFACTURING METHOD)
THEREOF, SEMICONDUCTOR DEVICE COMPRISING)
SAID WIRING AND DRY ETCHING METHOD)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on August 12,
2004

Cristine M. Noll

Date: August 12, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Copies of the references are enclosed herewith for the Examiner's consideration.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

As a RCE is being filed herewith no fee is believed necessary. If a fee is required, please charge Deposit Account No. 50/1039.

Respectfully submitted,



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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Atty. Docket No.</u> SEL 194	<u>Serial No.</u> 09/615,449		
			<u>Applicant</u> Hideomi SUZAWA et al			
			<u>Filing Date</u> July 13, 2000	<u>Group</u> 2814		
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	4,233,109	11/11/80	Nishizawa	156	643	07/12/78
	4,885,074	12/05/89	Susko et al	204	298	04/26/89
	5,716,534	02/10/98	Tsuchiya et al	216	67	11/29/95
	5,824,606	10/20/98	Dible et al	438	729	03/29/96
	5,883,007	03/16/99	Abraham et al	438	714	12/20/96
	6,239,403 B1	05/29/01	Dible et al	219	121.43	02/03/00
	6,259,106 B1	07/10/01	Boegli et al	250	492.22	01/06/99
	US 2001/ 0030322 A1	10/18/01	Yamazaki et al	257	59	02/02/01
	US 2001/ 0049197 A1	12/06/01	Yamazaki et al	438	689	06/04/01
	US 2001/ 0052950 A1	12/20/01	Yamazaki et al	349	43	03/16/01
	US 2001/ 0055841 A1	12/27/01	Yamazaki et al	438	151	04/12/01
	US 2002/ 0006705 A1	01/17/02	Suzawa et al	438	279	05/10/01
	US 2002/ 0013022 A1	01/31/02	Yamazaki et al	438	166	05/09/01
	US 2002/ 0016028 A1	02/07/02	Arao et al	438	149	06/05/01
	US 2002/ 0017685 A1	02/14/02	Kasahara et al	257	347	05/03/01
	6,357,385 B1	03/19/02	Ohmi et al	118	723	10/05/98
	6,365,917 B1	04/02/02	Yamazaki	257	72	11/16/99
	6,423,242 B1	07/23/02	Kojima et al	216	79	11/10/99
	6,431,112 B1	08/13/02	Sill et al	118	723	05/04/00
	US 2002/ 0110941 A1	08/15/02	Yamazaki et al	438	25	01/26/01
	6,475,836 B1	11/05/02	Suzawa et al	438	149	03/28/00
	6,515,336 B1	02/04/03	Suzawa et al	257	350	09/18/00
	6,534,826 B2	03/18/03	Yamazaki	257	336	04/27/00
	6,556,702 B1	04/29/03	Rishton et al	382	144	01/06/99
	6,686,228 B2	02/03/04	Suzawa et al	438	149	07/03/02
	6,753,257 B2	06/22/04	Yamazaki	438	689	12/27/02

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	APPLICANT	English Abstract	English Trans.	FILING DATE
	JP 10-326772	12/08/98	Ricoh Co. Ltd.	X		05/26/97

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

EL-KAREH, B., "Fundamentals of Semiconductor Processing Technologies,"
Kluwer Academic Publishers, p. 285, (1998).

EXAMINER:**DATE CONSIDERED:**

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.